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Intellectual Property Law

10/757638

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Linda H. Liu

December 7, 2005

Certificate DEC 15 2005 of Correction

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Title: TECHNIQUE FOR HIGH EFFICIENCY METALORGANIC CHEMICAL
VAPOR DEPOSITION

Letters Patent No. 6,921,710 B2

Issued: July 26, 2005

Our Reference: MICRON.140DV1C1

Dear Sir:

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP

A handwritten signature in black ink, appearing to be "LH Liu".

Linda H. Liu
Registration No. 51,240
Customer No. 20,995

Enclosures

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120505

Orange County
949-760-0404

San Diego
619-235-8550

San Francisco
415-954-4114

Los Angeles
310-551-3450

San Luis Obispo
805-547-5580

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UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,921,710 *B2*

DATED : July 26, 2005

INVENTOR(S): Weimin Li et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

At Column 10, Line 34, please delete "(methylcyclopentadienyl)" and insert therefore, --
(methylcyclopentadienyl)--

MAILING ADDRESS OF SENDER:

Linda H. Liu
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Irvine, California 92614

PATENT NO. 6,921,710

December 7, 2005

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FORM PTO 1050

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